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AMENDMENT UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE  
GROUP 1792  
PATENT APPLICATION

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q85281

Yuji EGUCHI, et al.

Appln. No.: 10/518,013

Group Art Unit: 1792

Confirmation No.: 1952

Examiner: Binh X. Tran

Filed: December 14, 2004

For: OXIDE FILM FORMING METHOD AND OXIDE FILM FORMING APPARATUS

**AMENDMENT UNDER 37 C.F.R. § 1.116**

**MAIL STOP AF**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated October 23, 2009, please amend the above-identified application as follows on the accompanying pages.

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